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RESPONSE UNDER 37 CFR 1.116-  
EXPLAINED PROCEDURE EXAMINING  
GROUP 2814

DOCKET NO: 219723US-2S

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

HAJIME NAGANO ET AL.

SERIAL NO: 10/078,344

FILED: FEBRUARY 21, 2002

FOR: SEMICONDUCTOR DEVICE  
USING PARTIAL SOI SUBSTRATE AND  
MANUFACTURING METHOD THEREOF

**COPY**

: EXAMINER: NGO, N.

: GROUP ART UNIT: 2814

AMENDMENT

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated August 8, 2003, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.

Docket No. 219723US-2S

IN RE APPLICATION OF: Hajime NAGANO ET AL.

SERIAL NO: 10/078,344

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FOR: SEMICONDUCTOR DEVICE USING PARTIAL SOI SUBSTRATE AND MANUFACTURING METHOD  
THEREOF

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313



RESPONSE UNDER 37 CFR 1.116  
EXAMINER'S PROCEDURE EXAMINING  
GROUP 2814

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SIR:

Transmitted herewith is an amendment in the above-identified application.

- No additional fee is required
- Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
- Additional documents filed herewith:

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS
TOTAL	8	MINUS	25	0	x \$18 =	\$0.00
INDEPENDENT	2	MINUS	3	0	x \$86 =	\$0.00
		<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS			+ \$290 =	\$0.00
						TOTAL OF ABOVE CALCULATIONS
		<input type="checkbox"/> Reduction by 50% for filing by Small Entity				\$0.00
		<input type="checkbox"/> Recordation of Assignment			+ \$40 =	\$0.00
						TOTAL
						\$0.00

- A check in the amount of \$0.00 is attached.
- Credit card payment form is attached to cover the fees in the amount of \$0.00
- Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.

Eckhard H. Kuesters

Registration No. 28,870

Customer Number

22850

Tel. (703) 413-3000  
Fax. (703) 413-2220  
(OSMMN 05/03)

David A. Bilodeau  
Registration No. 42,325



OSMM&N File No. 219723US-2S  
Serial No. 10/078,344

Dept.: E/M  
By: EHK/DAB/des

In the matter of the Application of: Hajime NAGANO ET AL.

For: SEMICONDUCTOR DEVICE USING PARTIAL SOI SUBSTRATE AND  
MANUFACTURING METHOD THEREOF

✓ Due Date: 11/08/03

The following has been received in the U.S. Patent Office on the date stamped hereon:

- Dep. Acct. Order Form
- Letter/Cover
- Amendment

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